

# APPLICATION DATA SHEET

Electronic Version v14

Stylesheet Version v14.0

<b>Title of Invention</b>	SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME
Application Type :	regular, utility
Attorney Docket Number :	031032
Correspondence address:	
Customer Number:	23850
	
Priority Data:	
Doc.No: 2002-255473; Country -JP ; Date: 2002-08-30 us-priority-claimed	
Inventor Information:	
<u>Inventor 1:</u>	
<b>Applicant Authority Type:</b>	Inventor
<b>Citizenship:</b>	JP
<b>Given Name:</b>	Takuji
<b>Family Name:</b>	TANAKA
<b>Residence:</b>	
<b>City of Residence:</b>	Kawasaki
<b>Country of Residence:</b>	JP
<b>Address-1 of Mailing Address:</b>	c/o FUJITSU LIMITED
<b>Address-2 of Mailing Address:</b>	1-1, Kamikodanaka 4-chome, Nakahara-ku
<b>City of Mailing Address:</b>	Kawasaki
<b>State of Mailing Address:</b>	
<b>Postal Code of Mailing Address:</b>	211-8588
<b>Country of Mailing Address:</b>	JP
<b>Phone:</b>	
<b>Fax:</b>	
<b>E-mail:</b>	
Attorney Information:	
practitioner(s) at Customer Number:	
23850	
	

as my attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.

Publication Information:

Suggested Figure for Publication -

Suggested Classification -

Suggested Technology Center -

Total Number of Drawing Sheets - 7

Assignee 1:

**Organization Name:**

FUJITSU LIMITED

**Address-1 of Mailing Address:**

1-1, Kamikodanaka 4-chome

**Address-2 of Mailing Address:**

Nakahara-ku

**City of Mailing Address:**

Kawasaki

**State of Mailing Address:**

211-8588

**Postal Code of Mailing Address:**

JP

**Country of Mailing Address:**

**Phone:**

**Fax:**

**E-mail:**